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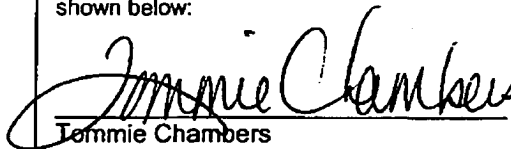
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NAME OF INVENTOR(S): Jaiswal	RECEIPT DATE & SERIAL NO.: Serial No.: 10/679,783 Filing Date: 10/6/2003
TITLE OF INVENTION: CONTROL OF NICHROME RESISTOR TEMPERATURE COEFFICIENT USING RF PLASMA SPUTTER ETCH	
TI FILE NO.: TI-34403.1	DEPOSIT ACCT. NO.: 20-0668
FAXED: 11-15-04 DUE: 10/28/2004 ATTY/SECY: WDS/tlc	

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Jaiswal
Serial No: 10/679,783
Filed: 10/6/2003
For: CONTROL OF NICHROME RESISTOR TEMPERATURE COEFFICIENT
USING RF PLASMA SPUTTER ETCH

Docket No: TI-34403.1
Examiner: McDonald, Rodney Glenn
Art Unit: 1753

AMENDMENT UNDER 37 C.F.R. § 1.115

Assistant Commissioner For Patents
Washington, DC 20231

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Tommie Chambers

Dear Sir:

Responsive to the Office Action mailed July 28, 2004 in connection with the
above identified application, Applicants respectfully submit the following amendments
and remarks.

TI-34403.1 - 1 -